



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 4199**
Mikio YAMAHIRO et al. : **Attorney Docket No. 2003_1318A**
Serial No. 10/664,151 : **Group Art Unit 1621**
Filed September 17, 2003 : **Examiner Samuel A. Barts**
PRODUCTION PROCESS FOR
SILICON COMPOUND AND THE SAME : **Mail Stop: Amendment**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEE FOR THIS PATE TO DEPOSIT
ACCOUNT NO. 23-0975.

Sir:

Petition hereby is made for a three month extension of time to respond to the communication of
January 3, 2006.

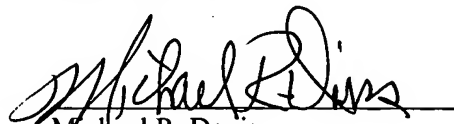
The fee of \$1,020.00 is

- ☒ submitted herewith.
☐ to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is
enclosed.
☐ Small entity status of this application is established by a Small Entity Status Assertion
which
☐ is enclosed.
☐ has been previously submitted.

Respectfully submitted,

Mikio YAMAHIRO et al.

By:


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July 3, 2006

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